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CLAIMS

1. A method for treating an implant surface intended for implantation into bone tissue c h a r a c t e r i s - e d in comprising:

providing fluorine and/or fluoride on at least a part of the implant surface, and

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providing a microroughness having a root-mean-square roughness (R_q and/or S_q) of ≤ 250 nm.

2. A method for treating an implant surface intended for implantation into bone tissue c h a r a c t e r i s - e d in comprising:

providing fluorine and/or fluoride on at least a part of the implant surface, and

providing a microroughness comprising pores having a pore diameter of \leq 1 μm and a pore depth of \leq 500 nm.

- 3. A method according to claim 2, wherein the pore diameter is within the range of 50 nm to 1 μm and the pore depth is within the range of 50 to 500 nm.
- 4. A method according to claim 2 or claim 3, wherein a root-mean-square roughness $(R_q \text{ and/or } S_q)$ of \leq 250 nm is provided.
 - 5. A method according to any one of claims 1-4, wherein an average atomic concentration of at least 0.2 at% fluorine and/or fluoride is provided.
 - 6. A method according to claim 5, wherein the average atomic concentration of fluorine and/or fluoride is within the range of 0.4-7 at%.
- 7. A method according to any one of claims 1-6, wherein the implant surface is a metallic implant surface.
 - 8. A method according to claim 7, wherein the fluorine and/or fluoride and the microroughness are provided by treating the metallic implant surface with an aqueous solution of hydrofluoric acid.
 - 9. A method according to claim 8, wherein the concentration of the hydrofluoric acid is less than 0.5 M.

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- 10. A method according to claim 9, wherein the metallic implant surface is treated for an etching period of up to 180 sec at room temperature.
- 11. A method according to claim 10, wherein the concentration of the hydrofluoric acid is 0.1 M and the etching period is up to 60 sec at room temperature.
- 12. A method according to any one of claims 1-11, further comprising providing a macroroughness on the implant surface prior to providing the fluorine and/or fluoride and prior to providing the microroughness.
- 13. A method according to claim 12, wherein the macroroughness is provided by blasting the implant surface.
- 14. A method according to any of claims 7-13, wherein said metallic implant surface is made of commercially pure titanium or an alloy of titanium.
- 15. An implant for implantation into bone tissue having an implant surface at least part of which has been treated with a method according to any of claims 1-14.
- 16. An implant for implantation into bone tissue 20 having an implant surface c h a r a c t e r i s e d in that at least a part of the implant surface comprises fluorine and/or fluoride, and a microroughness having a root-mean-square roughness (Rq and/or Sq) of ≤ 250 nm.
- 17. An implant for implantation into bone tissue
 25 having an implant surface c h a r a c t e r i s e d in
 that at least a part of the implant surface comprises
 fluorine and/or fluoride, and a microroughness which comprise pores having a pore diameter of ≤ 1 μm and a pore
 depth of ≤ 500 nm.
- 18. An implant according to claim 17, wherein the pore diameter is within the range of 50 nm to 1 μ m and the pore depth is within the range of 50 to 500 nm.
 - 19. An implant according to claim 17 or claim 18, wherein the microroughness has a root-mean-square roughness (R_q and/or S_q) of \leq 250 nm.
 - 20. An implant according to any one of claims 16-19, wherein the microroughness comprises peaks having a peak

width, at half the pore depth, of from 15 to 150% of the pore diameter.

- 21. An implant according to any one of claims 16-20, wherein at least a part of the implant surface has an average atomic concentration of at least 0.2 at% fluorine and/or fluoride.
- 22. An implant according to claim 21, wherein the average atomic concentration of fluorine and/or fluoride is within the range of 0.4-7 at%.
- 23. An implant according to any one of claims 16-22, wherein the implant surface further comprises a macroroughness.
 - 24. An implant according to any one of claims 16-23, wherein said implant is a metallic implant.
- 25. An implant according to claim 24, wherein said metallic implant is made of commercially pure titanium or an alloy of titanium.
 - 26. An implant according to any one of claims 16-25, wherein the implant is a dental implant.
- 27. An implant according to any one of claims 16-25, wherein the implant is an orthopaedic implant.

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